

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tomoe MIYAZAWA et al.

Group Art Unit: 2812

Application No.: 10/695,773

Filed: October 30, 2003

Docket No.: 117641

For:

MALEIC ACID AND ETHYLENE UREA CONTAINING FORMULATION FOR

REMOVING RESIDUE FROM SEMICONDUCTOR SUBSTRATE AND METHOD FOR

**CLEANING WAFER** 

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- $\boxtimes$ This Information Disclosure Statement is being filed (a) within three months of 1. the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- M 2. Relevance of references 1-2 and 5 is discussed in the present specification.
- $\boxtimes$ The present application was filed or entered the U.S. National Stage of the PCT after June 30, 2003. In accordance with the June 11, 2003, Notice waiving the requirements of 37 C.F.R. §1.98(a)(2)(i), copies of any U.S. patents and patent application publications are not attached.
- $\boxtimes$ English-language Abstracts of the non-English language references 6 and 7 are attached hereto.



5. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 6 and 7.

Respectfully submitted,

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Date: March 3, 2004

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INFORMATION DISCLOSURE STATEMENT								•		
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EXAMINER									SUB	
INITIAL	ļ	DOCUMENT NUMBER	DATE		NAME		CLASS	CLASS		
	1.	5,334,332	8/2/1994		LEE					
	2.	US 2003/0143495 A1	7/31/2003 8/16/2001		ISHIKAWA et al.					
	3.	US 2001/0014534 A1			AOKI et al.					
	4.	US 6,423,480 B2	7/23/2002		ICHIKI					
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FOREIGN PATENT DOCUMENTS										
		DOCUMENT NUMBER		DATE	COUNTE	COUNTRY		CLASS	SUB CLASS	
	5.	EP 0 662 705 B1	8/23/2000 7/2/1999		EUROPE					
	6.	JP A 11-174690 w/abstract & transl.			JAPAN					
	7.	JP A 2001-51429 w/abstract & transl.	2/2:	3/2001	JAPAN					
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)										
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Date: March 3, 2004